



13/C
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hiroshi SONOBE

Serial No.: 09/557,088

Group Art Unit: 2133

Filed: April 21, 2000

Examiner: Matthew C. Dooley

For: SEMICONDUCTOR INSPECTION METHOD

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PRELIMINARY AMENDMENT

MAR 19 2004

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Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Technology Center 2100

Sir:

Prior to further examination of the above-identified application, and subsequent to entry of the Amendment Under 37 CFR §1.116 filed on December 22, 2003, please amend the claims of this application: